IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| In re the application of: | |) . | |
|-----------------------------|--------------------------|--|--|
| | Toshihisa NOZAWA, et al. |) | |
| U.S. Serial No.: 10/583,847 | |) Group Art Unit: To Be Assigned | |
| Filed: June 21, 2006 | |) Examiner: To Be Assigned | |
| For: | | MPERATURE CONTROLLING METHOD FOR SUBSTRATE OCESSING SYSTEM AND SUBSTRATE PROCESSING SYSTEM | |

FORMAL DRAWING TRANSMITTAL

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Submitted herewith are eight (8) formal drawing sheets which are to replace the originally filed drawing sheets. The enclosed drawings are respectfully submitted to satisfy all formal drawing requirements.

If for any reason the enclosed drawings are not deemed to satisfy all formal drawing requirements, telephone contact with the undersigned attorney is respectfully requested.

Respectfully submitted,

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Date: July 15, 2008